



P2000,0145

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By: \_\_\_\_\_

Date: Dec. 1, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/923,701 Confirmation No. 1576  
Applicant : Anne Kurtenbach et al.  
Filed : August 6, 2001  
TC/A.U. : 1763  
Examiner : Parviz Hassanzadeh  
Title: : Apparatus and Method for Removing an Organic  
Material from a Semiconductor Device

Docket No. : P2000,0145

Customer No. : 24131

BOX AF

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE under 37 C.F.R. § 1.116**

S i r :

In response to the final Office action dated September 4, 2003, please consider the following remarks or arguments:

Remarks/Arguments begin on page 2 of this paper.